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Docket No. 740756-2641

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Takeshi Fukunaga

Serial No. 10/632,930

Filed: August 4, 2003

For: PROCESS FOR PRODUCTION OF SOI
SUBSTRATE AND PROCESS FOR
PRODUCTION OF SEMICONDUCTOR DEVICE

)

) Group Art Unit: 2823

) Examiner: William M. Brewster

) Confirmation No. 3789

) Date: September 22, 2004

AMENDMENT

U.S. Patent and Trademark Office
220 20th Street S.
Customer Window, Mail Stop _____
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

In response to the Office Action mailed June 22 2004, Applicant responds as follows: